	Application No.	Applicant(s)	
No. Commercial States	10/051,985	SAITO ET AL.	
Notice of Allowability	Examiner	Art Unit	
	Peter B. Kim	2851	
The MAILING DATE of this communication appeal claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIOF the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in thi or other appropriate communic GHTS. This application is subj	s application. If not include ation will be mailed in due	ed course. <b>THIS</b>
<ol> <li>This communication is responsive to</li> <li>The allowed claim(s) is/are <u>1-34</u>.</li> </ol>			
<ol> <li>The allowed claim(s) israte 1-34.</li> <li>The drawings filed on 16 January 2002 are accepted by the Examiner.</li> </ol>			
<ul> <li>4.  Acknowledgment is made of a claim for foreign priority unc</li> <li>a)  All b)  Some* c)  None of the:</li> </ul>			
<ol> <li>Certified copies of the priority documents have</li> </ol>	been received.		
2. Certified copies of the priority documents have been received in Application No			
<ol> <li>Copies of the certified copies of the priority doe         International Bureau (PCT Rule 17.2(a)).     </li> </ol>	cuments have been received in	this national stage applicat	tion from the
* Certified copies not received:	-d25 H.C.C. \$ 440/-> /b		
<ul> <li>5. Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).</li> <li>(a) The translation of the foreign language provisional application has been received.</li> </ul>			
6. Acknowledgment is made of a claim for domestic priority un		21.	
Applicant has THREE MONTHS FROM THE "MAILING DATE" of below. Failure to timely comply will result in ABANDONMENT of			
7. A SUBSTITUTE OATH OR DECLARATION must be submINFORMAL PATENT APPLICATION (PTO-152) which gives reas			NOTICE OF
<ul> <li>8.  ☐ CORRECTED DRAWINGS must be submitted.</li> <li>(a) ☐ including changes required by the Notice of Draftsper</li> <li>1) ☐ hereto or 2) ☐ to Paper No</li> <li>(b) ☐ including changes required by the proposed drawing of the proposed drawing drawing</li></ul>	-	·	Examiner.
(c) including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No. 82003.			
Identifying indicia such as the application number (see 37 CFR 1 each sheet.	.84(c)) should be written on the c	frawings in the front (not the	back) of
9. DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT FOR T			Note the
Attachment(s)			
<ul> <li>1 □ Notice of References Cited (PTO-892)</li> <li>3 □ Notice of Draftperson's Patent Drawing Review (PTO-948)</li> <li>5 ☑ Information Disclosure Statements (PTO-1449), Paper No</li></ul>	100 A Interview S 6 Examiner's	formal Patent Application (I ummary (PTO-413), Paper Amendment/Comment Statement of Reasons for a	No

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## EXAMINER'S AMENDMENT AND REASONS FOR ALLOWANCE

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Angus Gill on August 26, 2003.

The application has been amended as follows: on page 4, line 7 of specification, Change "DOS" to "DOF".

The following changes to the drawings have been approved by the examiner and agreed upon by applicant: Figure 13 should be labeled "Prior Art". In order to avoid abandonment of the application, applicant must make these above agreed upon drawing changes.

The following is an examiner's statement of reasons for allowance: None of the prior art of record teaches or discloses an exposure method comprising the step of arranging a transparent plate that includes a thin film, within a range that near field light from the thin film may operate on the object and the light transmittance of the thin film changes according to an intensity of light of incidence in combination with the step of exposing the object with near field light generated by the projecting a pattern on a mask onto the thin film of the transparent plate.

None of the prior art of record teaches an exposure apparatus comprising a transparent plate that includes a thin film, within a range that near field light from the thin film may operate on the object and the light transmittance of the thin film changes according to an intensity of

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light of incidence in combination with a projection optical system for projecting a pattern on a mask onto the thin film and for exposing the object with the near field light.

None of the prior art of record teaches or discloses a device fabricating method using an exposure apparatus as discussed above in combination with the steps of exposing the object using the exposure apparatus and performing a predetermined process for the object exposed.

None of the prior art of record teaches or discloses a device fabricating method using an exposure apparatus as discussed above.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Peter Kim whose telephone number is (703) 305-0105. The examiner can normally be reached on Monday-Thursday from 8:30 AM to 6:00 PM. The examiner can also be reached on alternate Fridays during the same hours.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Russ Adams can be reached on 703 308 2847. The fax phone numbers for the organization where this application or proceeding is assigned is 703 872-9306.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703 306- 3431.

Peter B. Kim Peter B. Kim Patent Examiner 8/26/03